

Abstract

An electret condenser **2** includes a fixed electrode **6**, a vibrating electrode **5**, an electretized silicon oxide film **7** formed between the electrodes, and silicon nitride films **8** and **9** formed so as to cover the silicon oxide film **7**. The silicon oxide film **7** covered **5** with the silicon nitride films **8** and **9** is formed on the vibrating electrode **5**.